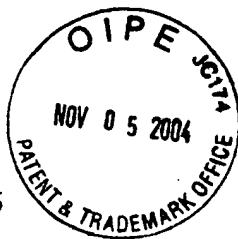


Docket No.: 52775-025



ITW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Masahiro NAKAYAMA, et al.	:	Confirmation Number: 6895
	:	
Application No.: 10/665,483	:	Group Art Unit: 1772
	:	
Filed: September 22, 2003	:	Examiner: Alexander S. Thomas
	:	
For: NITRIDE SEMICONDUCTOR WAFER AND METHOD OF PROCESSING NITRIDE SEMICONDUCTOR WAFER		

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of October 14, 2004 wherein restriction has been required, Applicant hereby elects Group II (claims 10-20) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,
MCDERMOTT WILL & EMERY LLP

Gene Z. Robinson
Registration No. 33,351

600 13th Street, N.W.
Washington, DC 20005-3096
202.756.8000 GZR:lnm
Facsimile: 202.756.8087
Date: November 5, 2004
WDC99 1001755-1.052775.0025